



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/594,475                      Group Art Unit: 1793  
Filing Date: September 28, 2006              Examiner: M. MARCHESCHI  
Applicant: Yoshiharu OHTA et al.  
Title: SEMICONDUCTOR POLISHING COMPOSITION  
Attorney Docket: 2691-000058/US

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Randolph Building  
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Alexandria, VA 22314  
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October 20, 2008

**AMENDMENT UNDER 37 C.F.R. §1.114**

Sir:

In response to the Office Action mailed May 19, 2008, and upon entry of the Request for Continued Examination, the shortened statutory period for reply being extended to October 19, 2008, by the attached Extension of Time, the following amendments and remarks are respectfully submitted.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 4 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
<b>Total</b>	4	-	20	=	0
<b>Independent</b>	1	-	3	=	0